

Attorney Docket No: 42390.P61



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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Miller et al.

Application No.: 09/280,268

Filed: March 29, 1999

For: CERIC-ION BASED SLURRY  
FOR METAL CMP

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Examiner: Deo, D.

Art Unit: 1765

Box Non-Fee Amendment  
Commissioner For Patents  
Washington, D.C. 20231

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TECHNOLOGY CENTER 1700

AMENDMENT AND RESPONSE

In response to the Office Action mailed on May 25, 2001, Applicants respectfully request the Examiner to enter the following amendments and consider the following remarks.

IN THE DRAWINGS

In accordance with 37 CFR § 1.121, please find attached proposed amendment to Figure 1d, in which proposed amendment to Figure 1d is marked in red. Also enclosed is a corrected (clean) drawing sheet 1 of 1 including the amended Figure 1d. The replacement of the original drawing with the corrected drawing is respectfully requested. The original Figure 1d had a duplicate reference number, 122, which referred to a different element in Figure 1c. Amended Figure 1d changes this reference number to 123.